



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 1765  
Examiner: Ms. Patricia Ann George

In re PATENT APPLICATION of:

Applicant :	Toyokazu SAKATA	)	
Serial No. :	10/721,260	)	
Filed :	November 26, 2003	)	<u>AMENDMENT</u>
For :	ETCHING METHOD AND SEMICONDUCTOR DEVICE FABRICATING METHOD	)	
Attorney Ref. :	TAI 145	)	

February 14, 2006

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present Amendment is being filed concurrently with a Request for Continued Examination (RCE) in order to permit further prosecution.

A fee of \$ 790 is being submitted concurrently. Should this remittance be accidentally missing, however, or should any additional fees be needed, the Director may charge such fees to our Deposit Account number 18-0002.

Please amend the above-identified application as specified on the following pages, and then reconsider the application in view of the Remarks that are presented thereafter.